



PATENT
81784.0301

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mitsuru OKIGAWA

Serial No: 10/773,088

Filed: February 5, 2004

For: SEMICONDUCTOR INTEGRATED DEVICE
INCLUDING SUPPORT SUBSTRATE
FASTENED USING RESIN, AND
MANUFACTURING METHOD THEREOF

Art Unit: 2891

Examiner: Luan C. Thai

PETITION FOR EXTENSION OF TIME

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence
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April 17, 2006

Date of Deposit

John P. Scherlacher, Reg. No. 23,009

Name

John P. Scherlacher 04/17/06

Signature

Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a one-month extension of time extending to April 21, 2006, the
period for response to the Final Office Action dated December 21, 2005. Please
charge the fee of \$120 for this extension to Deposit Account No. 50-1314. The
responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

John P. Scherlacher
John P. Scherlacher

Registration No. 23,009

Attorney for Applicant(s)

Date: April 17, 2006

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